

THURSDAY Nov. 10th

8:15	Morning Introduction LEE STENEKEN APOMA	
8:30	Laser Damage Measurements & Novel High Power Laser Metrology MIKE THOMAS SPICA TECHNOLOGIES	8:30am
9:00	Fabrication Methods and Challenges of Freeform Optics DAVE MOHRING OPTIPRO	
10:00	Coffee Break — [Sponsored by HERAEUS]	NIST MORNING
10:15	Optimizing Your Polishing Process with the Proper Pad/Polish Combination GARY ANDRESKI + DAVID SCHAWARZ NGL GROUP	TOUR
11:00	Increasing Throughput of Direct Energy Beam Directors MIKE HYMAN OPTIMAX	
		11:30am
Noon	Lunch Break - Sponsored by Spica Technologies	
1:00	Radiation Hardness of Fused Silica HERAEUS	1:00pm
1:45	Deterministic Pitch Polishing JUSTIN MAHANNA UNIVERSAL PHOTONICS	
2:45	Snack Break – [Sponsored by PR Hoffman]	NIST
3:00	International Trade Regulations and Government Contracting KERRY SCARLOTT NORTHSTAR LAW	AFTERNOON TOUR
3:45	Day 1 - Closing Statements LEE STENEKEN APOMA	
4:00	Happy Hour — [Sponsored by Schott]	3:45pm



FRIDAY | Nov. 11th

8:25	Morning Introduction LEE STENEKEN APOMA	
8:30	New Developments in ISO Standards DAVE AIKENS SAVVY OPTICS	
9:15	Understanding Coolants and Trizact CHRIS RUSSELL UNIVERSAL PHOTONICS	
10:00	Coffee Break — [Sponsored by HERAEUS]	
10:15	Useful Rules-of-Thumb for Optical Fabrication TAYYAB SURATWALA LAWRENCE LIVERMORE NATIONAL LABS	
11:15	Differences and Effects of Two Machine Concepts on the Manufacturing Process of Aspherical and Freeform Lenses MATTHIAS PFAFF OPTOTECH	
Noon	Lunch Break - Sponsored by Spica Technologies	
1:00	How Mechanical and Chemical Reactions Impact Ultra-Low Roughness Polishing JAYSON NELSON EDMUNDS OPTICS	
1:45	How the Optical Manufacturing Apprenticeship Program can Help Your Company ALEXIS VOGT + ROSS MICALI MONROE COMMUNITY COLLEGE	
2:30	Snack Break — [Sponsored by PR Hoffman]	
2:45	Front Range Community College AMANDA MEIER FRCC	
3:00	The Two Primary Missions of AmeriCOM JEFF RUCKMAN AMERICOM	
3:15	Tribute to John Grievenkamp Presentation SPIE	
3:30	Workshop Conclusion LEE STENEKEN APOMA	